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INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

(Chapter II of the Patent Cooperation Treaty)

(PCT Article 36 and Rule 70)

Apply						
Applicant's or agent's file reference 200300817-2 WO	FOR FURTHER A	ACTION	See Form PCT/IPEA/416			
International application No. PCT/GB2004/002983	International filing date 09.07.2004	e (day/month/year)	Priority date (day/month/year) 12.07.2003			
International Patent Classification (H05K3/20, H05K3/46, H01L)	IPC) or national classification and 23/538	IPC				
Applicant HEWLETT-PACKARD DEV	ELOPMENT COMPANY, L	P. et al.				
Authority under Article 35	ional preliminary examination and transmitted to the applica	report, established by	y this International Preliminary Examining le 36.			
1	f a total of 6 sheets, including	this cover sheet.				
3. This report is also accom	panied by ANNEXES, compri	sing:				
a. 🗵 sent to the applicant and to the International Bureau) a total of 6 sheets, as follows:						
and/or sheets	description, claims and/or draw containing rectifications authors Instructions).	wings which have bee orized by this Authorit	en amended and are the basis of this report by (see Rule 70.16 and Section 607 of the			
☐ sheets which beyond the di Supplementa	isclosure in the international a	which this Authority opplication as filed, as	considers contain an amendment that goes indicated in item 4 of Box No. I and the			
sequence listing a	national Bureau only) a total of and/or tables related thereto, in equence Listing (see Section	n computer readable	umber of electronic carrier(s)) , containing a form only, as indicated in the Supplemental trive Instructions).			
4. This report contains indic	cations relating to the following	g items:				
☐ Box No. I Basis o	⊠ Box No. I Basis of the opinion					
·	•					
☐ Box No. III Non-es						
⊠ Box No. V Reaso applica						
	Certain defects in the international application					
	n observations on the internati	ional application				
Date of submission of the demand	<u></u> j	Date of completion	of this report			
10.05.2005		06.10.2005	06.10.2005			
Name and mailing address of the Preliminary examining authority:	international	Authorized Officer				
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INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY

International application No. PCT/GB2004/002983

-	Box No. I Basis of the report					
1.	1. With regard to the language, this report is based on the international application in the languistied, unless otherwise indicated under this item.					
	☐ This report is based on tran which is the language of a t	slations from the original language into the following language, ranslation furnished for the purposes of:				
	☐ international search (und☐ publication of the international preliminary	der Rules 12.3 and 23.1(b)) ational application (under Rule 12.4) examination (under Rules 55.2 and/or 55.3)				
2.	2. With regard to the elements* of the international application, this report is based on (replacement shee have been furnished to the receiving Office in response to an invitation under Article 14 are referred to report as "originally filed" and are not annexed to this report):					
	Description, Pages	•				
	1, 4-10	as originally filed				
	2, 3	filed with the demand				
	Claims, Numbers					
	12(part), 13-20, 27(part), 28-36	as originally filed				
	1-11, 12(part), 21-26, 27(part), 37	filed with the demand				
	Drawings, Sheets	•				
	1/4-4/4	as originally filed				
	a sequence listing and/or a	ny related table(s) - see Supplemental Box Relating to Sequence Listing				
3.	☐ The amendments have res	The amendments have resulted in the cancellation of:				
	\Box the description, pages					
	☐ the claims, Nos.☐ the drawings, sheets/figs	_				
	the drawings, sheets/ligs					
		equence listing (specify):				
4.	This report has been established as if (some of) the amendments annexed to this report and listed below had not been made, since they have been considered to go beyond the disclosure as filed, as indicated in the Supplemental Box (Rule 70.2(c)).					
	☐ the description, pages☐ the claims, Nos.☐ the drawings, sheets/figs☐ the sequence listing (sp	ecify):				
	☐ any table(s) related to se	equence listing (specify):				
	* If item 4 applies, so	ome or all of these sheets may be marked "superseded "				

INTERNATIONAL PRELIMINARY REPORT **ON PATENTABILITY**

International application No. PCT/GB2004/002983

Reasoned statement under Article 35(2) with regard to novelty, inventive step or industrial Box No. V applicability; citations and explanations supporting such statement

1. Statement

Novelty (N)

Yes: Claims

3-9,13-23,25-35

Claims No:

1,2,10-12,24,36,37

Inventive step (IS)

Yes: Claims Claims No:

none

Yes: Claims

1-37

Industrial applicability (IA)

Claims No:

1-37 none

2. Citations and explanations (Rule 70.7):

see separate sheet

Box No. VII Certain defects in the international application

The following defects in the form or contents of the international application have been noted:

see separate sheet

Box No. VIII Certain observations on the international application

The following observations on the clarity of the claims, description, and drawings or on the question whether the claims are fully supported by the description, are made:

see separate sheet

Re Item V

Reasoned statement with regard to novelty, inventive step or industrial applicability; citations and explanations supporting such statement

Reference is made to the following document:

D1: US-A-4 159 222 (LEBOW SANFORD ET AL) 26 June 1979 (1979-06-26)

The broad language used in the claims does not allow the subject matter to be clearly distinguished over the prior art, and in particular, over document D1 (see the comments below referring Item VIII). The examiner considers that a "physical" interconnection exists in the cross-over structure disclosed in document D1. This document discloses two alternatives of forming the interconnection in two steps: (a) electroplating followed by etching, and (b) electroless deposition of a thin layer followed by electrodeposition.

Insofar as the examiner can understand the claims, the following is pointed out:

- 1. Document D1 discloses (col. 4, l. 40 col. 5, l. 25, Figs. 6 and 7A) a cross-over of first and second separate elongate conductive interconnects, the cross-over comprising:
 - a first elongate conductive interconnect;
 - a second elongate conductive interconnect comprising:
 - a first conductive portion separate from the first conductive interconnect,
- a second conductive portion separate from the first conductive interconnect and the first conductive portion, and
- a third electro-deposited metal portion 62 physically interconnecting the first and second conductive portions;

first insulating material 50 between the first elongate conductive interconnect 30 and the third portion 62 of the second elongate conductive interconnect; and

a substrate 72, wherein

the first insulating material 50 and the third portion 62 are positioned between the substrate 72 and the first elongate interconnect 30.

Thus, the subject matter of claim 1 appears not novel (Article 33(2) PCT).

2. The same reasoning applies, mutatis mutandis, to the subject matter of the corresponding independent method claim 24 and independent device claim 36, which does not define any technical features but only refers back to claim 24. The subject matter of said claims seems, therefore, also not new.

- 3. The first insulating material of the cross-over known from document D1 directly contacts the third electro-deposited metal portion. Consequently, the subject matter of independent claim 37 also appears to lack novelty.
- 4. Independent claim 23 as well as dependent claims 2 22 and 25 35 do not appear to contain any features which, in combination with the features of any claim to which they refer, meet the requirements of the PCT in respect of novelty and/or inventive step.

Re Item VII

Certain defects in the international application

- 1. Contrary to the requirements of Rule 5.1(a)(ii) PCT, the relevant background art disclosed in the document D1 is not mentioned in the description, nor is this document identified therein (see also the Guidelines, paragraph 4.05).
- 2. The features of the claims are not provided with reference signs placed in parentheses in order to facilitate their understanding (Rule 6.2(b) PCT, see also the Guidelines, paragraph 5.11).

Re Item VIII

Certain observations on the international application

1. The application contains three independent claims directed to a cross-over, i.e. claims 1, 36 and 37. Thus, the number of independent claims seems unreasonable with respect to the nature of the invention which the applicant seeks to protect (Rule 6.1(a) PCT).

Lack of clarity of the claims as a whole arises, since the plurality of claims directed to the same subject matter makes it difficult, if not impossible, to determine the matter for which protection is sought, and places an undue burden on others seeking to establish the extent of the protection.

The requirements of Article 6 PCT regarding conciseness and clarity are, therefore, not met (see also the Guidelines, paragraph 5.42).

2. The term "physically" having a very broad meaning, it is not possible to distinguish clearly and unambiguously the subject matter of independent claim 1, 24 and 37 over the

INTERNATIONAL PRELIMINARY REPORT ON PATENTABILITY (SEPARATE SHEET)

International application No.

PCT/GB2004/002983

prior art.

Similarly, the broad wording of claim 1 does not exclude an interconnection formed in two steps, for example, electroplating followed by etching, or electroless deposition of a seed layer followed by electrodeposition.

- 3. Claim 36 is independent as it refers to claims of a different category. Such a claim should define clearly all essential features of the invention. However, no proper features of a cross-over are specified in said claim (see the Guidelines, paragraph 5.33).
- 4. The last part of the description (page 10, last two paragraphs) implies that the subject matter for which protection is sought may be different to that defined by the claims. This results in lack of clarity of the claims (Article 6 PCT) when the description is used to interpret them (see the Guidelines, paragraph 5.30).

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interconnects. For example, circuitry with a matrix of conductive interconnects, such as matrix display devices, may have thousands or millions of such cross-overs.

- In the bulk semi-conductor field, the conductive interconnects are normally separated into different electrically insulated layers of the semiconductor device. Vias through the insulating layers of the device are used to form electrical connection to the conductive interconnects.
- In some applications, such as display devices, it is desirable to have a thin device and it is undesirable to separate, into separate electrically insulated layers, the conductive interconnects that cross-over.
- It would be desirable to provide a cross-over for conductive interconnects without separating the conductive interconnects into different insulated layers.

BRIEF DESCRIPTION OF THE INVENTION

The inventor has realized that a cross-over of first and second interconnects can be formed by bridging the first conductive interconnect using electrodeposited metal that forms part of the second interconnect.

According to one embodiment of the invention there is provided a cross-over of first and second separate elongate conductive interconnects, comprising: a first elongate conductive interconnect; a second elongate conductive interconnect comprising: a first conductive portion separate from the first elongate conductive interconnect; a second conductive portion separate from the first elongate conductive interconnect and the first conductive portion; and a third electro-deposited metal portion physically interconnecting the first and second conductive portions; and first insulating material between the first elongate conductive interconnect and the third electro-deposited metal portion of the

second elongate interconnect; and a substrate, wherein the first insulating material and the third electro-deposited metal portion are positioned between the substrate and the first elongate conductive interconnect.

According to another embodiment of the invention there is provided a crossover of first and second conductive means, comprising: first conductive means;

second conductive means comprising: a first conductive portion separate from the first conductive means; a second conductive portion separate from the first conductive means and the first conductive portion; and a third electrodeposited metal portion physically interconnecting the first and second conductive portions; and first insulating means for insulating the first conductive means from the second conductive means wherein the first insulating means directly contacts the third electro-deposited metal portion.

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According to another embodiment of the invention there is provided a method of crossing a first elongate conductive interconnect and a separate second elongate conductive interconnect in an integrated circuit, comprising:

a) forming a first elongate conductive interconnect; b) forming a first conductive portion separate from the first elongate conductive interconnect; c) forming a second conductive portion separate from the first elongate conductive interconnect; d) depositing first insulating material over at least a portion of the first elongate conductive interconnect; and e) electro-depositing metal to form a third electro-deposited metal portion extending over the first insulating material to physically interconnect the first and second conductive portions and form the second elongate conductive interconnect; and f) transferring the structure formed in steps a) to e) to a substrate.

The inventor has realized that a cross-over of first and second interconnects can be formed by bridging the first conductive interconnect using electrodeposited metal that forms part of the second interconnect before transfer to a final

CLAIMS

- 1. A cross-over of first and second separate elongate conductive interconnects, comprising:
- 5 a first elongate conductive interconnect;
 - a second elongate conductive interconnect comprising:
 - a first conductive portion separate from the first elongate conductive interconnect;
 - a second conductive portion separate from the first elongate conductive interconnect and the first conductive portion; and a third electro-deposited metal portion physically interconnecting the first and second conductive portions; and

first insulating material between the first elongate conductive interconnect and the third electro-deposited metal portion of the second elongate interconnect; and

a substrate,

wherein the first insulating material and the third electro-deposited metal portion are positioned between the substrate and the first elongate conductive interconnect.

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- 2. A cross-over as claimed in claim 1, wherein the first and second elongate conductive interconnects are formed from electro-deposited metal.
- A cross-over as claimed in claim 1 or 2, wherein the first elongate
 conductive interconnect has a necked portion adjacent the first insulating material.
 - 4. A cross-over as claimed in claim 3, wherein the first and second conductive portions are located on opposite sides of the necked portion of the first elongate conductive interconnect.
 - 5. A cross-over as claimed in claim 3 or 4, wherein the third electro-deposited metal portion bridges the first insulating layer where it is adjacent the necked

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portion of the first elongate conductive interconnect.

- 6. A cross-over as claimed in any preceding claim, having a first layer and a second layer, wherein the first elongate conductive interconnect occupies at least the first layer and the second elongate conductive interconnect occupies the first and second layers.
- 7. A cross-over as claimed in claim 6, wherein the first layer comprises at least a portion of the first elongate conductive interconnect, the first conductive portion, the second conductive portion and second insulating material between the first conductive portion and the first elongate conductive interconnect and between the second conductive portion and the first elongate conductive interconnect and the second layer comprises first insulating material adjacent at least a portion of the first elongate conductive interconnect, and the third interconnecting metal portion.
 - 8. A cross-over as claimed in claim 7, wherein the first and second insulating material enclose a portion of the first elongate conductive interconnect.
- 9. A cross-over as claimed in any preceding claim, wherein the first insulating material forms a layer that is elongated in the same direction as the elongate first conductive layer.
 - 10. A cross-over as claimed in any preceding claim, wherein the first elongate conductive layer is formed wholly from metal.
 - 11. A cross-over as claimed in any preceding claim, wherein the first elongate conductive layer comprises electro-deposited metal.
- 12. A cross-over as claimed in any preceding claim, wherein the first elongate conductive interconnect is formed from the same material as the first and second

- 21. A cross-over as claimed in claim 20, wherein the substrate is flexible
- 22. A cross-over as claimed in claim 20 or 21, wherein the substrate is made from plastics.

- 23. An active-matrix display, comprising a plurality of cross-overs as claimed in any preceding claim.
- 24. A method of crossing a first elongate conductive interconnect and a separate second elongate conductive interconnect in an integrated circuit, comprising:
 - a) forming a first elongate conductive interconnect;
 - b) forming a first conductive portion separate from the first elongate conductive interconnect;
- c) forming a second conductive portion separate from the first elongate conductive interconnect;
 - d) depositing first insulating material over at least a portion of the first elongate conductive interconnect; and
- e) electro-depositing metal to form a third electro-deposited metal portion
 20 extending over the first insulating material to physically interconnect the first
 and second conductive portions and form the second elongate conductive
 interconnect; and
 - f) transferring the structure formed in steps a) to e) to a substrate.
- 25. A method as claimed in claim 24, wherein step d) involves forming a first insulating layer over a necked portion of the first elongate conductive interconnect.
- 26. A method as claimed in claim 24 or 25, wherein step d) involves the selective retention of photo-curable material.
 - 27. A method as claimed in any one of claims 24 to 26, wherein, in step a), the

37. A cross-over of first and second conductive means, comprising: first conductive means;

second conductive means comprising:

a first conductive portion separate from the first conductive means; a second conductive portion separate from the first conductive means and the first conductive portion; and

a third electro-deposited metal portion physically interconnecting the first and second conductive portions; and

first insulating means for insulating the first conductive means from the second conductive means wherein the first insulating means directly contacts the third electro-deposited metal portion.